

EAST - [10754004.wsp |]

File View Edit Tools Window Help

Drafts
 Pending
 Active
 L1: (13) optoelectronic and heat near transfer near fluid
 L2: (22) optoelectronic and heat near fluid
 L3: (2) heat adj transfer adj fluid near substrate
 Failed
 Saved
 (3) ("6713866").PN
 (13) optoelectronic and heat near transfer near fluid
 Favorites
 Tagged (0)
 UDC
 Queue
 Trash

Browse Queue Clear
 DBs USPAT:EPD:JPO:DERW Plurals
 Default operator: OR ☒ Highlight all hit terms initially

optoelectronic and heat near transfer near fluid

BRST ISOP Image Text HTML

	U	I	Document ID	Issue Date	Pages	Title	Current OR	Current XRef
1	<input type="checkbox"/>	<input type="checkbox"/>	US 6713866 B2	20040330	8	Cooling of optoelectronic elements	257/714	385/14; 385/16;
2	<input type="checkbox"/>	<input type="checkbox"/>	US 6692568 B2	20040217	38	Method and apparatus for producing MIIN columns and MIIN materials grown	117/84	117/106; 117/89;
3	<input type="checkbox"/>	<input type="checkbox"/>	US 6678168 B2	20040113	47	System including power conditioning modules	361/764	
4	<input type="checkbox"/>	<input type="checkbox"/>	US 6658861 B1	20031209	14	Cooling of high power density devices by electrically conducting fluids	62/3.7	62/259.2
5	<input type="checkbox"/>	<input type="checkbox"/>	US 6606251 B1	20030812	42	Power conditioning module	361/764	
6	<input type="checkbox"/>	<input type="checkbox"/>	US 6523443 B1	20030225	13	Process for manufacturing optical surfaces and shaping machine for carrying out this	82/1.4	82/11.3; 82/118;
7	<input type="checkbox"/>	<input type="checkbox"/>	US 6508885 B1	20030121	23	Edge sealing structure for substrate in low-pressure processing environment	118/728	156/345.51; 216/71;
8	<input type="checkbox"/>	<input type="checkbox"/>	US 6073576 A	20000613	23	Substrate edge seal and clamp for low-pressure processing equipment	118/723E	118/52; 118/728;

Version 1.3.1 - 101272901093003 All EAST - [10754004] EAST Browser - L2 [...]